

MS AF
PATENT
8074-1143

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Koichi NANIWAE Conf. 9283

Application No. 10/573,492 Group 2892

Filed May 15, 2006 Examiner E. Jones

METHOD OF CLEANING TREATMENT AND METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

SUPPLEMENTAL RESPONSE AFTER FINAL REJECTION

Assistant Commissioner for Patents May 27, 2010
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the Official Action of February 19, 2010 and
is supplemental to the response filed May 19, 2010.

Remarks begin on page 2 of this paper.